

<b>Notice of References Cited</b>	Application/Control No. 10/591,919	Applicant(s)/Patent Under Reexamination TANIGUCHI ET AL.	
	Examiner REBECCA LEE	Art Unit 1793	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,423,426 B1	07-2002	Kobayashi et al.	428/659
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
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	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Machine translation of JP2003239040
	V	Machine translation of JP06108152
	W	Machine translation of JP05331537
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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